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TABLE OF CONTENTS

Monday, 11 August 2008

M1	Nano Particles & Nanowires	
M1.1	Advances in Quantum Dots and 2D/3D Photonic Crystal Nanocavity based on Micro-Machining Technology	1
M1.2	Spectral Reflectance Measurement of Two-Dimensional Photonic Nanocavities with Embedded Quantum Dots	3
M1.3	Synthesis and Characterization of ZnO Nanorod Arrays and Their Integration into Polymer Solar Cells	5
M1.4	Parallel Assembly of Nanowires Using Lateral-Field Optoelectronic Tweezers	7
M1.5	Sub-30nm Alignment Accuracy between Layered Photonic Nanostructures using Optimized Nanomagnet Arrays	9
M2	Microfluidics and Biosensors	
M2.1	How Can We use Nanophotonics to Help in Combating Climate Change?	11
M2.2	Low-Power Consumption Integrated Laser Doppler Blood Flowmeter with a Built-in Silicon Microlens	13
M2.3	Reconfigurable Liquid Micro-Lens System for Variable Fiber Coupling	15
M2.4	High Resolution Integrated Microfluidic Fabry-Perot Refractometer in Silicon	17
M2.5	Pulsed Laser Triggered High Speed Microfluidic Switch	19
М3	Waveguide Devices	
M3.1	Optical Interconnects & Nanophotonics	21
M3.2	Silicon Microring Resonator Connected with Submicorn Comb Actuator	23
M3.3	Four Port Nanophotonic Couplers for Dense, Planar Integrated Optics	25
M3.4	A Novel Etching-Oxidation Fabrication Method for 3D Nano Structures on Silicon and Its Application to SOI Symmetric Waveguide and 3D Taper Spot Size Converter	27
М3.5	Coupled-Ring Reflector Laser Diodes Composed of Squared Ring Waveguides	29
M4	Light Sources and Displays	
M4.1	MEMS-based Pico Projector Display	31
M4.2	High-Efficiency MEMS Tuneable Gratings for External Cavity Lasers and Microspectrometers	33
M4.3	Optical Wavelength Selection and Amplification by Silica Microcavities and Erbium Doped iii	35

M4.4	Fiber Micropatterned Complex Optical Surface for Wide Angle Illumination	37
M4.5	Large Linear Micromirror Array for UV Femtosecond Laser Pulse Shaping	39
Tues	day, 12 August 2008	
Tu1	Biomedical Microsystems	
Tu1.1	Cooling and Amplifying Micro-Mechanical Motion with Light	41
Tu1.2	MEMS based Dual-Axes Confocal Clinical Endoscope for Real Time in vivo Imaging	42
Tu1.3	Tunable Multi-Micro-Lens System for High Lateral Resolution Endoscopic Optical Coherence Tomography	44
Tu1.4	Resonant Cantilever Bio Sensor with Integrated Grating Readout	46
Tu1.5	Design and Fabrication of Parylene-Hinged Slow-Scan Optical Scanner for OCT Endoscope Application	48
Tu2	Periodic-Structure Devices	
Tu2.1	Photonic Crystal Biosensors and Tunable Resonant Optical Devices	50
Tu2.2	Ultrahigh Sensitivity Slot-Waveguide Biosensor on a Highly Integrated Chip for Simultaneous Diagnosis of Multiple Diseases	52
Tu2.3	Nanostructured Effective-Index Micro-Optical Devices based on Blazed 2-D Sub-Wavelength Gratings with Uniform Features on a Variable-Pitch	54
Tu2.4	Characterization of Silicon-on-Insulator Waveguide Chirped Grating for Coupling to a Vertical Optical Fiber	56
Tu3	Microfabrication	
Tu3.1	Microspectrometer: From Ideas to Product	58
Tu3.2	Fabrication of Aberration-Corrected Tunable Micro-Lenses	60
Tu3.3	Three-Dimensional Integration of Optical Multi-Chips using Surface-Activated Bonding for High-Density Microsystems Packaging	62
Tu3.4	Pulsed Thermal Excitation of Luminescent Microparticles for Radiation Dosimetry	64
Tu3.5	Widely Tunable Fabry-Perot Optical Filter using Fixed-Fixed Beam Actuators	66
Tu4	Scanners and Applications	
Tu4.1	Impact of High Optical Power on Optical MEMS	68
Tu4.2	A High-Power Handling MEMS Optical Scanner for Display Applications	70

	Fast and High-Precision 3D Tracking and Position Measurement with MEMS Micromirrors	72					
Tu4.4	In-situ Single Cell Electroporation using Optoelectronic Tweezers	74					
Tu4.5	Large Area High-Reflectivity Broadband Monolithic Silicon Photonic Crystal Mirror MEMS Scanner	76					
Tu4.6	3D Imaging using Resonant Large-Aperture MEMS Mirror Arrays and Laser Distance Measurement	78					
Wedn	Wednesday, 13 August 2008						
W1	Metamaterials and Photonic Crystals						
W1.1	Photonic Metamaterials: Optics Starts Walking on Two Feet	80					
W1.2	Nanophotonics	82					
W1.3	Clarification of Electromagnetic Responses in Split-Ring Resonators from Electric Excitation	84					
W1.4	Large-Area Monolithic Photonic Crystal Mirrors with High Reflectivity in the 1250-1650nm Band Patterned by Optical Lithography	86					
W2	Adaptive Optics						
W2.1	Applications of LCoS-based Adaptive Optical Elements in Microscopy	88					
W2.2	MEMS Deformable Mirrors for Adaptive Optics using Single Crystal PMN-PT	90					
W2.3	A Varifocal Micromirror with Pure Parabolic Surface using Bending Moment Drive	92					
W2.4	Simulation and Characterization of Tunable Achromatic Micro-Lenses	94					
W2.5	Optical Scanner with Deformable Mirror Fabricated from SOI Wafer	96					
P	Poster Session						
P1	A Micromachined Vibratory Sub-Wavelength Diffraction Grating Laser Scanner	98					
P2	ZnO Nanorod-based Polymer Solar Cells with Optimized Electrodes	100					
Р3	Wafer Level Batch Fabrication and Assembly of Small Form Factor Optical Pickup Head	102					
P4	Evaluation of X-ray Reflectivity of a MEMS X-ray Optic	104					
P5	Design and Fabrication of CMOS-Integrated Thermoelectric IR Microsensors	106					
P6	Performance Improvement of a Two-Axis Radial-Vertical-Combdrive Scanner by using a Symmetric Spring Design	108					
P7	Assembly of Micro Mirrors on SOI Wafers using SU-8 Mechanisms and One-Push	110					

v

	Operation	
P8	Spatially Resolved Optical Characterization of Photonic Crystal Slabs using Direct Evaluation of Photonic Modes	112
P9	Micro-Mirror Array for Multi-Object Spectroscopy in Cryogenic Environment	114
P10	Low Operation Voltage Non Self-Emissive MEMS Color Filter Pixels	116
P11	White-Light Electroluminescence from ZnO Nanowires/Polyfluorene Heterojunction Diodes	118
P12	Stabilization of Temperature Characteristics of Micromirror for Low-Voltage Driving using Thin Film Torsion Bar of Tensile Poly-Si	120
P13	Simulation-based Design of a MEMS X-ray Optic for X-ray Astronomy	122
P14	Fabrication of Sub-Micrometer Si Spheres with Atomic-Scale Surface Smoothness using Homogenized KrF Excimer Laser Reformation System	124
P15	Space Instruments based on MOEMS Technology	126
P16	Polymer Biochips with Micro-Optics for LIF Detection	128
P17	3D Modeling of Photonic Devices using Dynamic Thermal Electron Quantum Medium Finite-Different Time-Domain (DTEQM-FDTD) Method	130
P18	High-Density Piezoelectric Actuator Array for MEMS Deformable Mirrors Composed of PZT Thin Films	132
P19	Monolithic Integration of a Tunable Photodetector Based on InP/Airgap Fabry-Pérot Filters	134
P20	Polarization Singularities and Local Field Symmetries in Photonic Crystals	136
P21	Polymer Deformable Membrane Mirrors for Focus Control using SU-8 2002	138
P22	Mechanically Coupled Comb Drive MEMS Stages	140
P23	Photonic Crystal Rods utilizing Fano Resonance for Tunable Filter Applications	142
P24	A Glass Cantilever Beam Sensor Combined with a Spherical Reflecting Mirror for Sensitivity Enhancement	144
P25	A Micromirror Scanner with Vertical Combs Tilted by Assembly Process	146
P26	Design and Fabrication of Etched Diffraction Grating Demultiplexers based on α-Si Nanowire Technology	148
P27	Planar Centering Mechanism for Dielectrically Liquid Lens	150
P28	The Two-Axis Magnetostatic-Drive Single-Crystal-Si Micro Scanner Driven by Back-side Electroplating Ni Film	152
P29	All-Optical Ultra-Compact Photonic Crystal Controllable Logic Gate	154
P30	Conductive Pattern Forming Method on Vertical Wall using Spray Coating and Angled Exposure Technologies	156
P31	A Novel Lens Formation Technology to Implement a 3D Spherical Polymer Lens vi	158

	Fabrication of 2D and 3D Photonic Quasi-Crystals with High Rotation Symmetry by Holographic Lithography Technique	160
P33	Fabrication of Wall-Coated Cs Vapor Cells for a Chip-Scale Atomic Clock	162
P34	The Torque-Enhancement Design for Magnetostatic Scanner	164
P35	Six Port Waveguide Filter based on Circular Photonic Crystal	166
P36	Towards Integration of Glass Microlens with Silicon Comb-Drive X-Y Microstage	168
P37	Optical Add/drop Filter Based on Dual Curved Photonic Crystal Resonator	170
Thurs	day, 14 August 2008	
Th1	Detectors and Imaging Systems	
Th1.1	Cavity-Optomechanics in Nanoscale Photonic Crystals	N/A
Th1.2	CMOS-SOI-MEMS Transistor (TMOS) for Infrared Imaging	172
Th1.3	Mid-Infrared Tunable Resonant Cavity Enhanced Detectors Employing Vertically Moving Comb Drive Actuated MEMS Micromirrors	174
Th1.4	A Dynamic Subwavelength Pitch Grating Modulator for Continuous Time-of-Flight Ranging with Optical Mixing	176
Th1.5	Radiation Heat Transfer Dominated Microbolometers	178
Th2	Nanofabrication and Characterization	
Th2.1	Near-Field Scanning Nanophotonic Microscopy	180
Th2.2	The Dependence of Poly-Crystalline SiC Mid-Infrared Optical Properties on Deposition Conditions	182
Th2.3	Impact of an Air Barrier on the Electron States of Etch-Released Quantum Heterostructures	184
Th2.4	Bandgap Tuning of Photonic Crystals by Polymer Swelling	186
Th2.5	Formation of a Nitrified Hafnium Oxide Buffer Layer on Silicon Substrate and GaN Quantum Well Crystal Growth for GaN-Si Hybrid Optical MEMS	188